

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/565,767 Confirmation No. 2990
Applicant : Yuichiro Shindo
371 Filed : January 24, 2006
Art Unit : 1793
Examiner : Mark L. Shevin
Customer No. : 00270
Title : HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN
FILM COMPRISING THE SAME, AND METHOD FOR
PRODUCING HIGHLY PURE HAFNIUM

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE) in response to a FINAL Office Action dated August 28, 2008. A Petition for a One Month Extension of Time is filed herewith to extend the deadline for response from November 28, 2008 to December 28, 2008. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.